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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/573,623 Confirmation No.: 5536  
Applicant: Nishida et al.  
Filed: 03/28/2006  
TC/A.U.: 1792  
Examiner: Fletcher III, William P.  
Docket No.: DC5181 PCT1  
Customer No.: 00137  
Date: 17 July 2008  
For: Method of Metallizing a Silicone Rubber Substrate

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office action dated 04/11/2008, Applicants respectfully request reconsideration of the above-identified case in view of the following amendment and remarks. A terminal disclaimer pursuant to 37 CFR 1.321 is enclosed herewith.

Page 1 of 7